

Moeller BPM Resolution

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8/21/2024

BPM Requirement Summary

Beam Position Monitor Requirements:

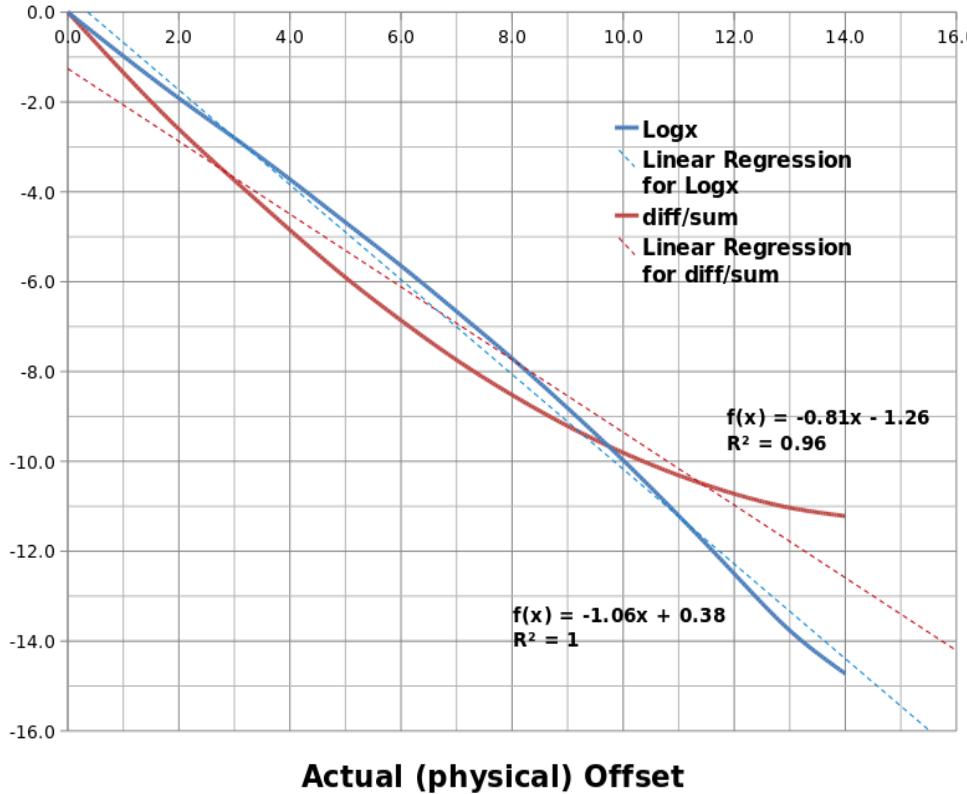
- <3 micron resolution at 960Hz (achieved in existing SEE M15)
- Known latency, high bandpass limit about 1 MHz (at least > 100 kHz, for integrate gate integrity)
- ~1% linear response over ~500 micron (i.e. $500\mu\text{m} \pm 5\mu\text{m}$)
- Position vs. charge, differential < 1 nm/ppb (has been achieved with careful calibration in SEE system)
- Position vs. charge, integral: 30-60uA , error in position $\delta x < 100 \mu\text{m}$
- Low current operation: at least two x/y BPMs, ~10m apart, with ~50 $\mu\text{m}\text{-Hz}$ resolution at 1-10 nA
- wish: Position vs. charge, differential < 0.05 nm/ppb (possible with linear digital receiver)

Algorithms (Approximations)

Difference-over-sum

$$X = k_x \frac{V_+ - V_-}{V_+ + V_-}$$

$$Y = k_y \frac{V_+ - V_-}{V_+ + V_-}$$

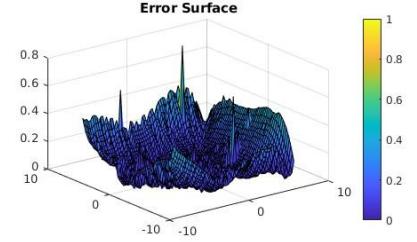
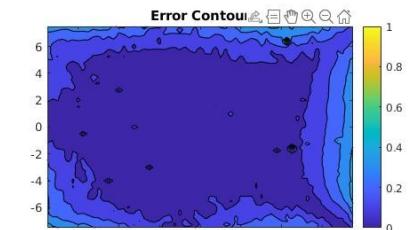
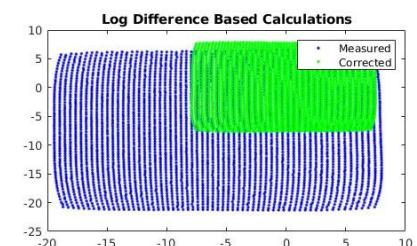
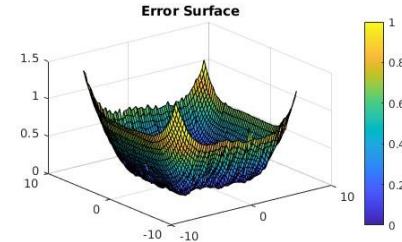
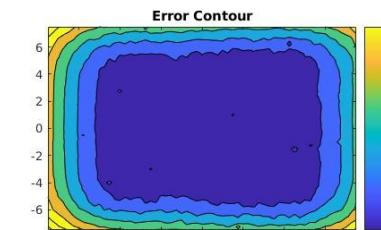
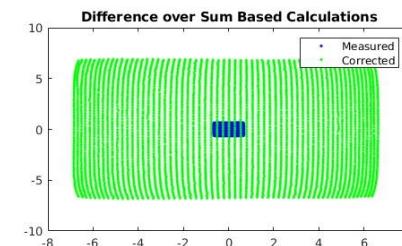


Difference of Logs

$$X = A_x \cdot [\log(V_+) - \log(V_-)]$$

$$Y = A_y \cdot [\log(V_+) - \log(V_-)]$$

Linear Fit



Log Fit

Resolution (Naive)

Propagation of Errors

(A review!)

Functional Form

Rule 1:

$$z = x + y$$

Uncertainty

$$\delta z = \sqrt{\delta x^2 + \delta y^2}$$

Rule 2:

$$z = x \cdot y$$

$$\frac{\delta z}{z} = \sqrt{\left(\frac{\delta x}{x}\right)^2 + \left(\frac{\delta y}{y}\right)^2}$$

Rule 3:

$$q = f(x_1, x_2, \dots, x_n)$$

$$\delta q = \sqrt{\left(\frac{\partial q}{\partial x_1} \delta x_1\right)^2 + \dots + \left(\frac{\partial q}{\partial x_n} \delta x_n\right)^2}$$

Diff-Over-Sum Resolution Analysis

Assumption: AWGN!!

Difference-over-sum:

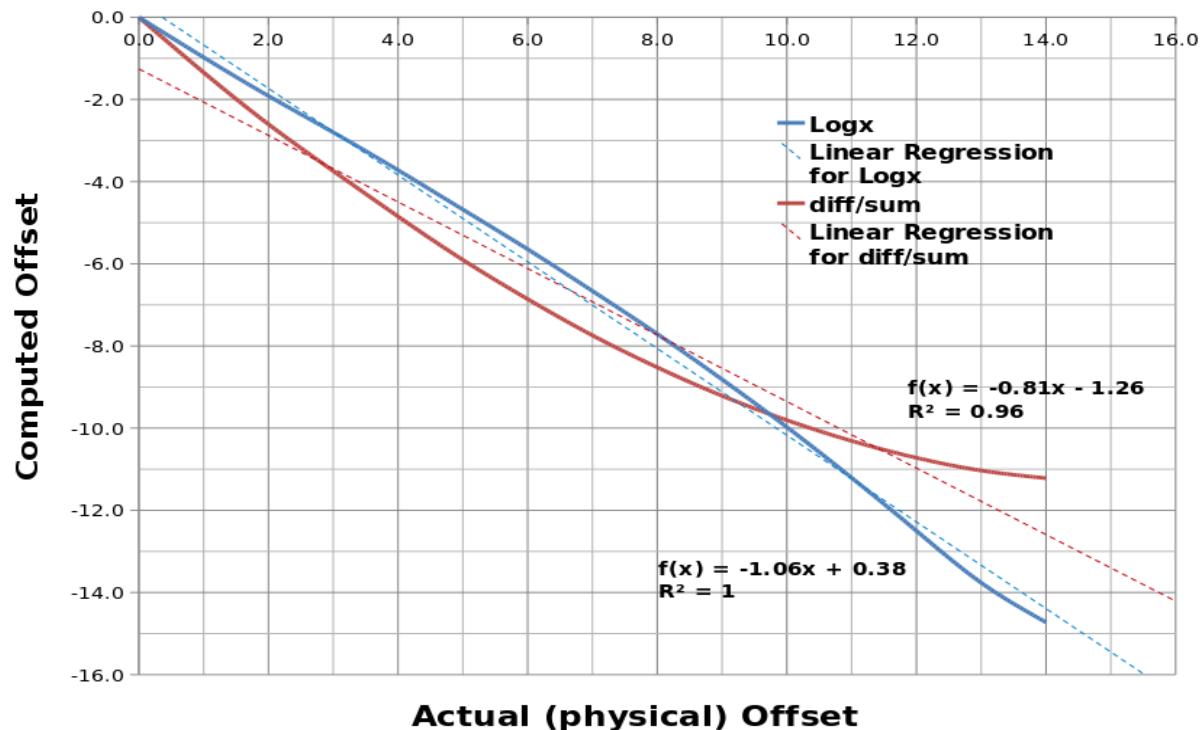
$$X = \frac{a}{2} \cdot \frac{V_L - V_R}{V_L + V_R}$$

$$\frac{\partial X}{\partial V_L} = \frac{a \cdot V_R}{(V_R + V_L)^2}$$

$$\frac{\partial X}{\partial V_R} = \frac{-a \cdot V_L}{(V_R + V_L)^2}$$

$$\sigma_X = \frac{a}{(V_R + V_L)^2} \cdot \sqrt{V_L^2 \delta V_R^2 + V_R^2 \delta V_L^2} \quad (\text{Rule #3})$$

At boresight....



$$\sigma_X = \frac{a}{2} \cdot \frac{\sqrt{2} \sigma_v}{2V} = \frac{a}{2\sqrt{2}} \cdot \frac{1}{\sqrt{SNR}}$$

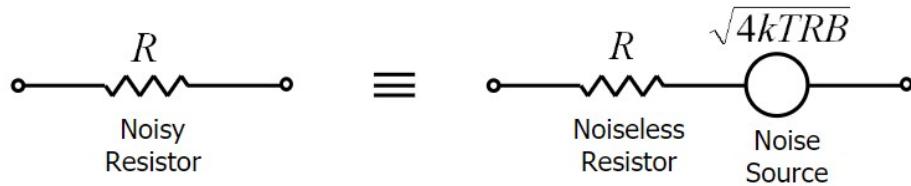
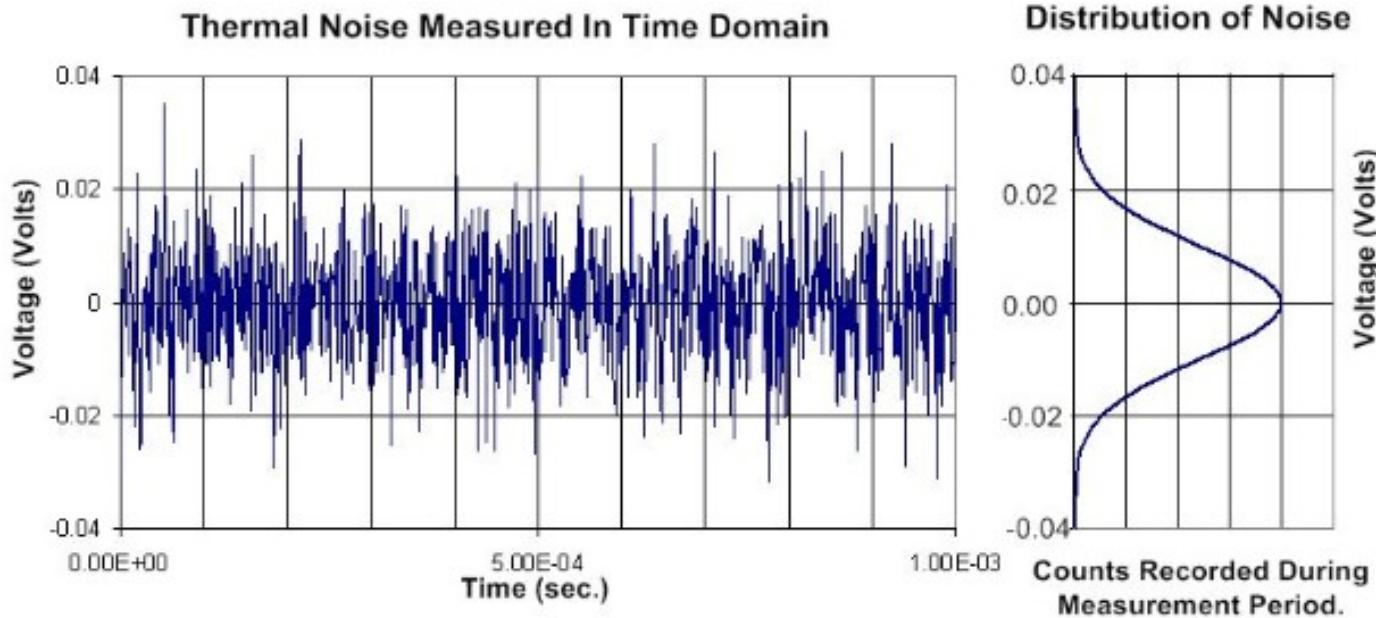
$$SNR = \frac{P_s}{P_n} = \frac{V_s^2}{V_n^2}$$

What is “Noise?”



Time Domain – White noise

normal distribution

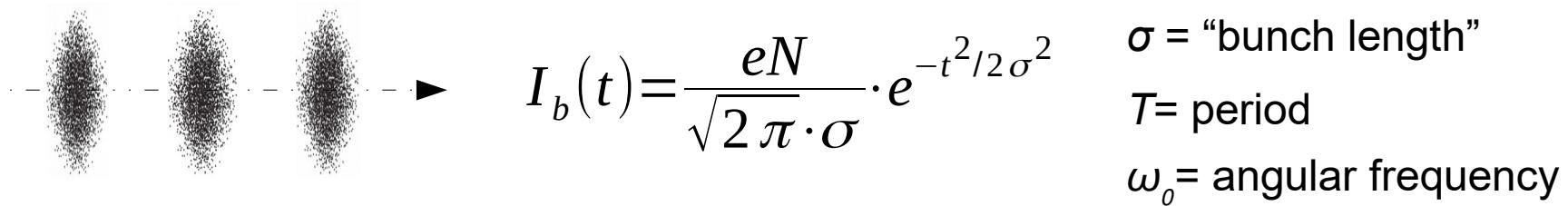


For $R = 50 \Omega$ at 300K:

$$P_n = k_B T B = -174 \text{ dBm/Hz}$$

We only have 2 knobs: T and B!.....

Gaussian Bunched Beam



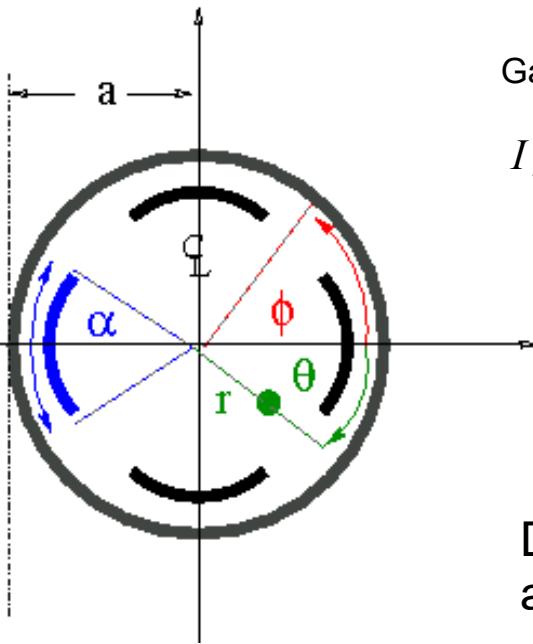
Fourier series:

$$I_b(t) = \frac{eN}{T} + \sum_{m=1}^{\infty} I_m \cos(m\omega_0 t) \rightarrow I_m = \frac{2eN}{T} \cdot e^{\frac{-m^2\omega_0^2\sigma^2}{2}}$$
$$= \langle I_b \rangle + 2\langle I_b \rangle \sum_{m=1}^{\infty} A_m \cos(m\omega_0 t)$$
$$\langle I_b \rangle = \frac{eN}{T} = eNf_0 \quad A_m = e^{\frac{-m^2\omega_0^2\sigma^2}{2}}$$

...we have the option to include as many terms as necessary...

Especially wrt integration, which is easy for $\cos()$!!

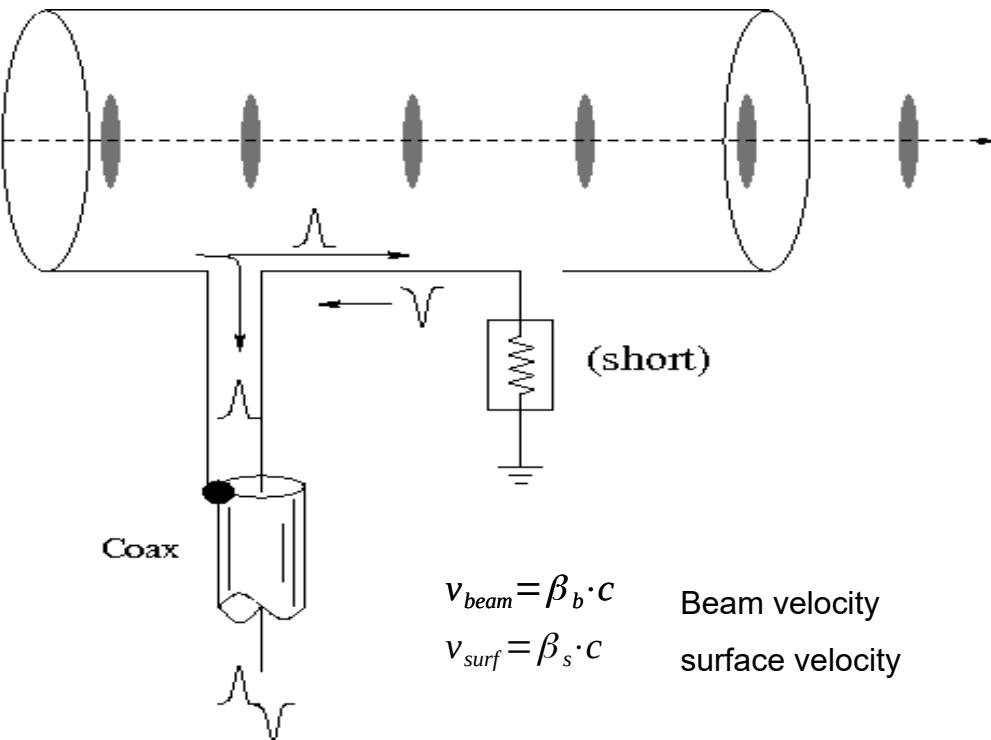
Stripline BPMs (Directional-Coupler Style)



Gaussian pulses...

$$I_{beam}(t) = I_0 \cdot e^{-t^2/2\sigma_t^2}$$

Directional Coupler
architecture.....



$$v_{beam} = \beta_b \cdot c$$

Beam velocity
surface velocity

Current

$$i_{\Im}(\phi) = \frac{I_{beam}}{2\pi a} \cdot \left(\frac{a^2 - r^2}{a^2 + r^2 - 2ar \cdot \cos(\phi - \theta)} \right)$$

$$I_{\Im} = \int_{-\alpha/2}^{+\alpha/2} a \cdot j_{\Im}(\phi) d\phi$$



Voltage

$$U_1(t) = \frac{1}{2} \frac{\alpha}{2\pi} \cdot R_1 \left(I_{beam}(t) - I_{beam}\left(t - \frac{2l}{c}\right) \right)$$

$$U_1(t) = \frac{Z_{strip}}{2} \frac{\alpha}{2\pi} \cdot \left(e^{-(t+\tau)^2/2\sigma_t^2} - e^{-(t-\tau)^2/2\sigma_t^2} \right) \cdot I_0$$

$$Z_t(\omega) = \frac{Z_{strip} \cdot \alpha}{4\pi} \cdot e^{-\omega^2 \sigma_t^2/2} \cdot \sin(\omega l/c) \cdot e^{i(\pi/2 - \omega l/c)}$$

Transfer Impedance

$$I_0 = \frac{eN}{\sqrt{2\pi}\sigma} \quad \tau = \frac{l}{2c} \cdot \left[\frac{1}{\beta_b} + \frac{1}{\beta_s} \right]$$

α = angular extent (θ_s , prior)

BPM Output Power

In the frequency domain, RF voltage is:

$$V(\omega) = \frac{\theta_s Z}{\sqrt{2\pi}} \langle I_b \rangle A(\omega) \cdot \sin\left[\frac{\omega l}{2c} \cdot \left(\frac{1}{\beta_s} + \frac{1}{\beta_b}\right)\right]$$

... which is maximized when "sin()" argument = $\pi/2$.

For electron beams, $\beta_b = \beta_s = 1$. Also, $A(\omega) \sim 2$.

Output power from our DC stripline is (per electrode, for boresight beam):

$$P_s = 2 \left(\frac{\theta_s}{2\pi} \right)^2 \cdot Z \cdot \langle I_b \rangle^2 A^2(\omega) \cdot \sin^2\left(\frac{\omega l}{c}\right)$$

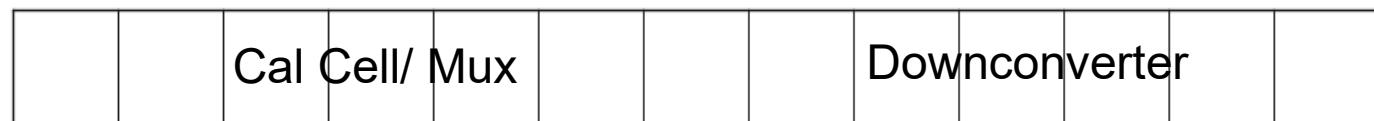
Which, when optimized by 1/4-wavelength stripline electrode:

$$P_s = 8 \cdot \left(\frac{\theta_s}{2\pi} \right)^2 \cdot Z \cdot \langle I_b \rangle^2$$

For our JLAB stripline BPM, we expect to see (and actually do!) -82 dBm for $I_{beam} = 1\text{uA}$. $Z = 50 \Omega$.

I = 50 uA
B = 100kHz

RECEIVER MODEL



Input Field

Coax	LNA	Filter	Amp	Coax	LNA	Filter	Amp	Filter	Mixer	IF Filter	Amp	ADC
4.00	1.30	3.00	5.40	12.00	1.30	3.00	5.40	1.00	8.00	6.00	2.70	25.00 dB
-4.00	13.00	-3.00	18.00	-12.00	13.00	-3.00	18.00	-1.00	-8.00	-6.00	31.00	0.00 dB
-4.00	13.00	-20.00	18.00	-12.00	13.00	-20.00	18.00	-20.00	-8.00	-30.00	31.00	0.00 dB
200.00	28.00	200.00	26.00	200.00	28.00	200.00	26.00	200.00	34.00	200.00	7.00	200.00 dBm
200.00	23.00	200.00	20.00	200.00	23.00	200.00	20.00	200.00	22.00	200.00	20.00	200.00 dBm
8.00	20.00	6.00	20.00	24.00	20.00	6.00	20.00	2.00	16.00	12.00	25.00	25.00 dB

Pin Interference

Pin Passband

Input Noise BW

Input Noise Temperature

Input Noise Level

Required C/N

Required Sensitivity

• 100

(System IF BW)

(IEEE definition = 290K for Physical Temperature)

(Modulator / BER -dependent... see BER sheet)

(From "Specifications" or "Standards")

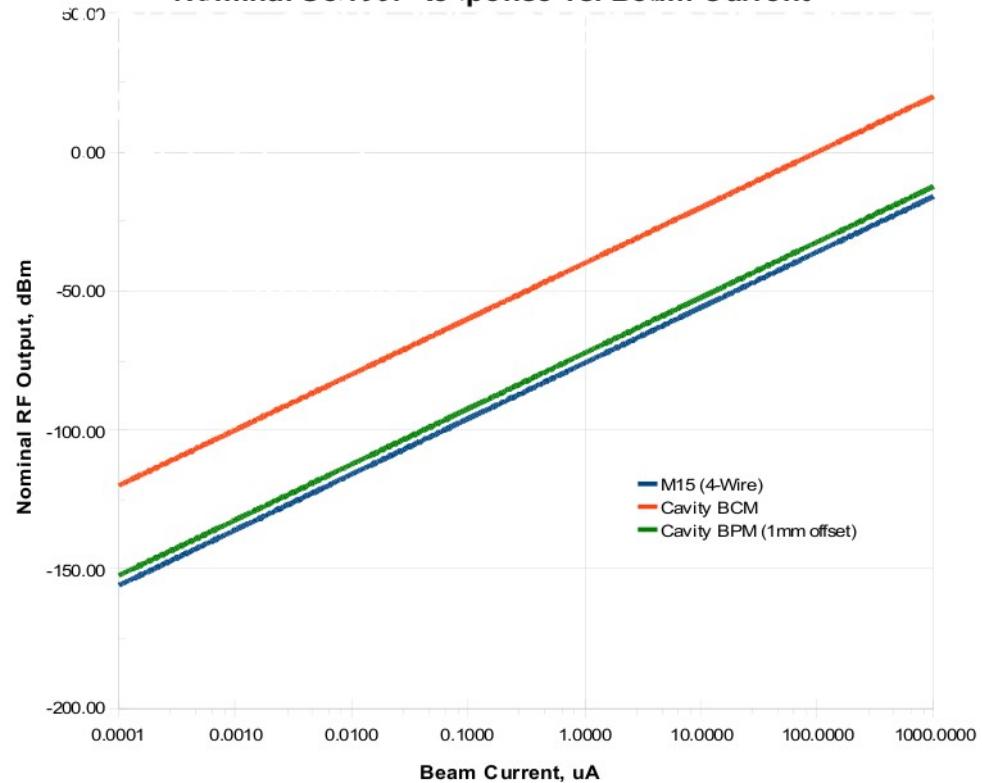
Calculation Field

4.00	5.30	5.46	6.16	6.22	6.25	6.25	6.27	6.27	6.27	6.27	6.28	6.30	dB
26.42	28.41	28.63	29.58	29.67	29.70	29.70	29.72	29.72	29.72	29.72	29.74	29.76	dBK
-4.00	9.00	6.00	24.00	12.00	25.00	22.00	40.00	39.00	31.00	25.00	43.00	43.00	dB
-4.00	9.00	-11.00	7.00	-5.00	8.00	-12.00	6.00	-14.00	-22.00	-52.00	26.00	26.00	dB
200.00	32.00	32.00	19.73	19.73	14.47	14.47	3.63	3.63	-5.56	-5.56	-5.01	-5.01	dBm
200.00	32.00	32.00	30.81	30.81	28.76	28.76	28.27	28.27	28.22	28.22	11.94	11.94	dBm
213.32	100.45	100.35	91.70	91.66	88.13	88.13	80.89	80.89	74.77	74.77	75.12	75.11	dB
-50.00	-37.00	-40.00	-22.00	-34.00	-21.00	-24.00	-6.00	-7.00	-15.00	-21.00	-3.00	-3.00	dBm
-50.00	-37.00	-57.00	-39.00	-51.00	-38.00	-58.00	-40.00	-60.00	-68.00	-98.00	-20.00	-20.00	dBm
-123.98	-109.68	-112.52	-93.81	-105.75	-92.73	-95.73	-77.71	-78.71	-86.71	-92.71	-74.70	-74.68	dBm
73.98	72.68	72.52	71.81	71.75	71.73	71.73	71.71	71.71	71.71	71.71	71.70	71.68	dB
NO	dB												
-538.00	-202.00	-202.00	-199.61	-199.61	-195.51	-195.51	-194.54	-194.54	-194.44	-194.44	-161.89	-161.89	dBm
492.00	156.00	156.00	153.61	153.61	149.51	149.51	148.54	148.54	148.44	148.44	115.89	115.89	dB
8.00	28.00	34.00	54.00	78.00	98.00	104.00	124.00	126.00	142.00	154.00	103.00	128.00	dB

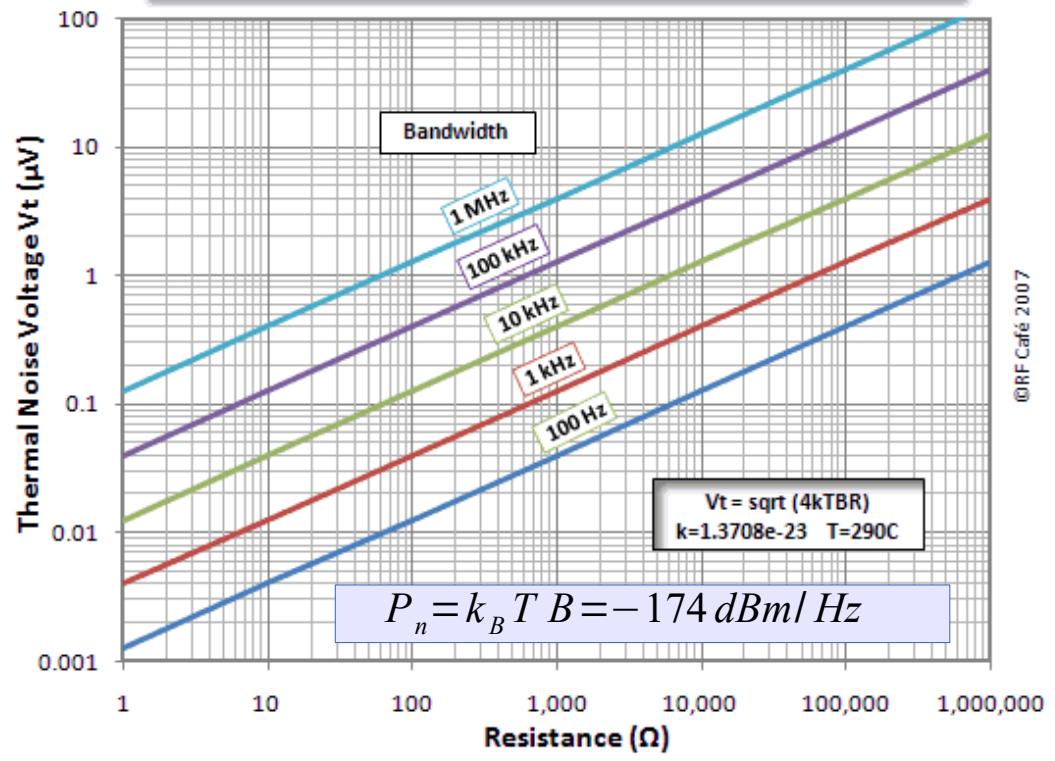
Calculated Receiver Sensitivity:

-79.68	dBm
-80.00	dBm
-0.32	dB

Nominal Sensor Response vs. Beam Current



Thermal Noise as a Function of Resistance and Bandwidth



Typical M15 output power = -46 dBm @ 50uA

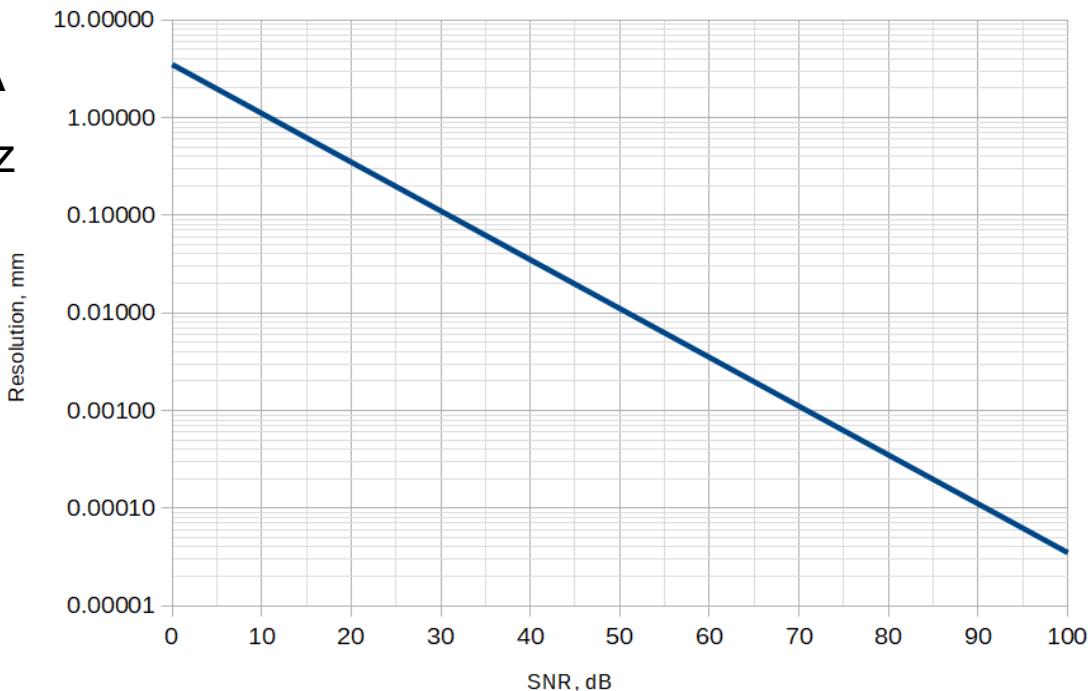
Expected noise power = -124 dBm for 100kHz

Calc. Rx SNR = 71 dB (B = 100 kHz)

$\Sigma = 1.9 \text{ um}$, $I = 50 \text{ uA}$, $B = 100 \text{ kHz}$

So, for M15 BPM:

$$\sigma \approx \frac{0.3 \text{ } \mu\text{m} \cdot \sqrt{\text{Hz}}}{\text{uA}}$$



Note: Resolution is NOT accuracy!!

$I = 10 \text{ nA}$

$B = 1 \text{ Hz}$

RECEIVER MODEL

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Input Field

Noise Figure

	Coax	LNA	Filter	Amp	Coax	LNA	Filter	Amp	Filter	Mixer	IF Filter	Amp	ADC
	4.00	1.30	3.00	5.40	12.00	1.30	3.00	5.40	1.00	8.00	6.00	2.70	25.00
	-4.00	13.00	-3.00	18.00	-12.00	13.00	-3.00	18.00	-1.00	-8.00	-6.00	60.00	0.00
	-4.00	13.00	-20.00	18.00	-12.00	13.00	-20.00	18.00	-20.00	-8.00	-30.00	60.00	0.00
	200.00	28.00	200.00	26.00	200.00	28.00	200.00	26.00	200.00	34.00	200.00	-22.00	200.00
	200.00	23.00	200.00	20.00	200.00	23.00	200.00	20.00	200.00	22.00	200.00	20.00	200.00
	8.00	20.00	6.00	20.00	24.00	20.00	6.00	20.00	2.00	16.00	12.00	25.00	25.00

dB

Gain: Passband

Gain: Reject-band

HIP3

P1dB

Return Loss

Pin Interference

Pin Passband

Input Noise BW

Input Noise Temperature

Input Noise Level

Required C/N

Required Sensitivity

<input type="button" value="1"/>	<input type="button" value="2"/>	<input type="button" value="3"/>
<input type="button" value="4"/>	<input type="button" value="5"/>	<input type="button" value="6"/>
<input type="button" value="7"/>	<input type="button" value="8"/>	<input type="button" value="9"/>
<input type="button" value="0"/>	<input button"="" type="button" value="dBm"/>	

-120.00 dBm
-120.00 dBm
0.00 dB-Hz
290.00 K
-174.0 dBm
38.00 dB
-80.00 dBm

(System IF BW)

(IEEE definition = 290K for Physical Temperature)

(Modulator / BER -dependent...see BER sheet)

(From "Specifications" or "Standards")



Calculation Field

System Noise Figure

System Noise Temp

System Gain: Passband

System Gain: Reject-band

HIP3: Passband

HIP3: Reject-band

Input Spurious-Free Dynamic Range

Pout: Passband

Pout: Reject-band

Output Noise Power

C/N Ratio

Saturation?

HIM3

C/I Ratio

Total Return Loss

4.00	5.30	5.46	6.16	6.22	6.25	6.25	6.27	6.27	6.27	6.27	6.27	6.28	6.28
26.42	28.41	28.63	29.58	29.67	29.70	29.70	29.72	29.72	29.72	29.72	29.72	29.74	29.74
-4.00	9.00	6.00	24.00	12.00	25.00	22.00	40.00	39.00	31.00	25.00	72.00	72.00	dB
-4.00	9.00	-11.00	7.00	-5.00	8.00	-12.00	6.00	-14.00	-22.00	-52.00	55.00	55.00	dB
200.00	32.00	32.00	19.73	19.73	14.47	14.47	3.63	3.63	-5.56	-5.56	-34.00	-34.00	dBm
200.00	32.00	32.00	30.81	30.81	28.76	28.76	28.27	28.27	28.22	28.22	-17.00	-17.00	dBm
246.65	133.78	133.68	125.03	124.99	121.46	121.46	114.22	114.22	108.10	108.10	89.13	89.13	dB
-124.00	-111.00	-114.00	-96.00	-108.00	-95.00	-98.00	-80.00	-81.00	-89.00	-95.00	-48.00	-48.00	dBm
-124.00	-111.00	-131.00	-113.00	-125.00	-112.00	-132.00	-114.00	-134.00	-142.00	-172.00	-65.00	-65.00	dBm
-173.98	-159.68	-162.52	-143.81	-155.75	-142.73	-145.73	-127.71	-128.71	-136.71	-142.71	-95.70	-95.70	dBm
49.98	48.68	48.52	47.81	47.75	47.73	47.73	47.71	47.71	47.71	47.71	47.70	47.70	dB
NO	NO												
-760.00	-424.00	-424.00	-421.61	-421.61	-417.51	-417.51	-416.54	-416.54	-416.44	-416.44	-326.00	-326.00	dBm
640.00	304.00	304.00	301.61	301.61	297.51	297.51	296.54	296.54	296.44	296.44	206.00	206.00	dB
8.00	28.00	34.00	54.00	78.00	98.00	104.00	124.00	126.00	142.00	154.00	103.00	128.00	dB

Calculated Receiver Sensitivity:

-129.70	dBm
-80.00	dBm
49.70	dB

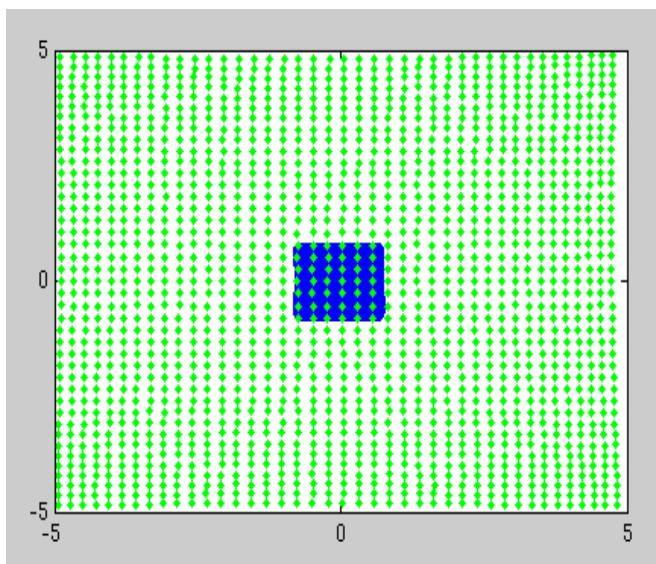
41 dB SNR >> 60um resolution

Required Receiver Sensitivity:

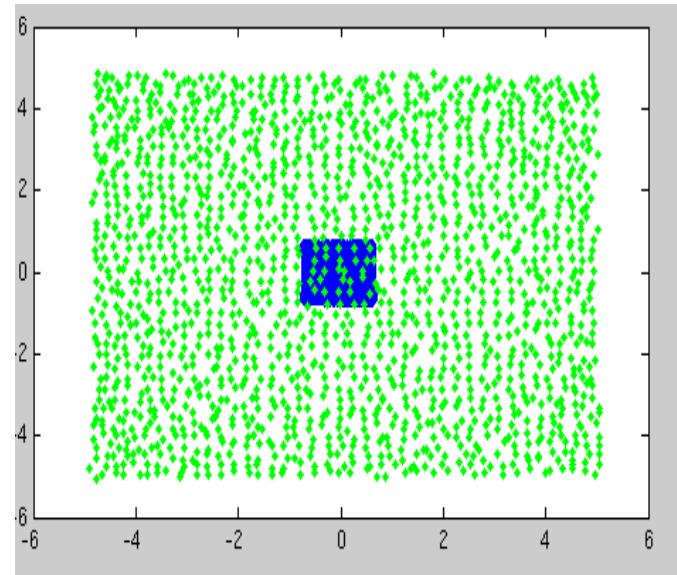
Margin:

Measured Resolution Examples

(Goubau Line, per J. Musson)

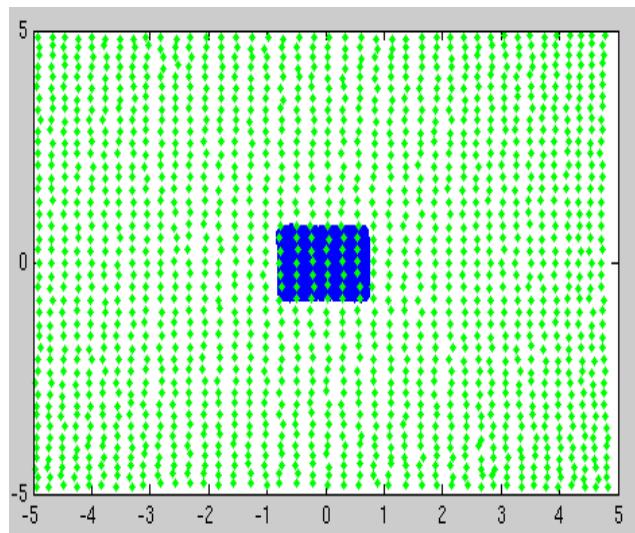


$I \sim 800\text{nA}$; $B = 10 \text{ Hz}$

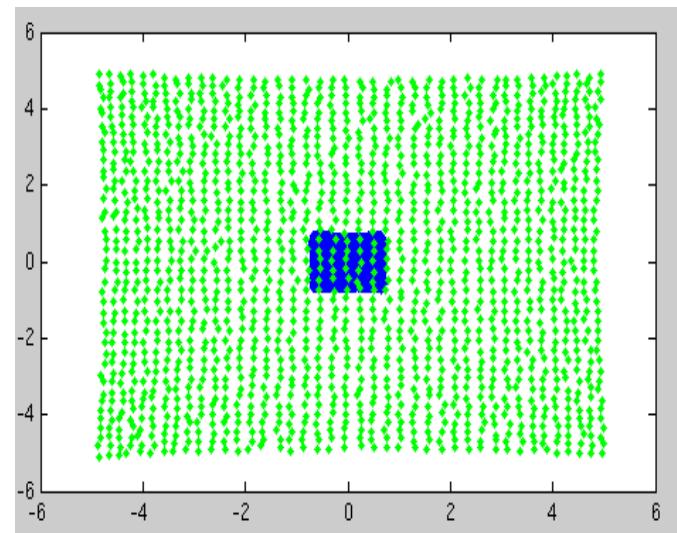


Step = 250 μm

$I \sim 100\text{nA}$; $B = 100 \text{ Hz}$



$I \sim 100\text{nA}$; $B = 10 \text{ Hz}$



$I \sim 70\text{nA}$; $B = 10 \text{ Hz}$

Statistical Communications: Formal Approach

“Bandpass White Gaussian Process”

Bayes' Theorem:

Signals and noise are bivariate!!

$$P(A | B) = \frac{P(B | A) \cdot P(A)}{P(B)} \quad (1)$$

$$P(A | B) = \frac{P(B | A) \cdot P(A)}{P(B | A) \cdot P(A) + P(B | \neg A) \cdot P(\neg A)} \quad (2)$$

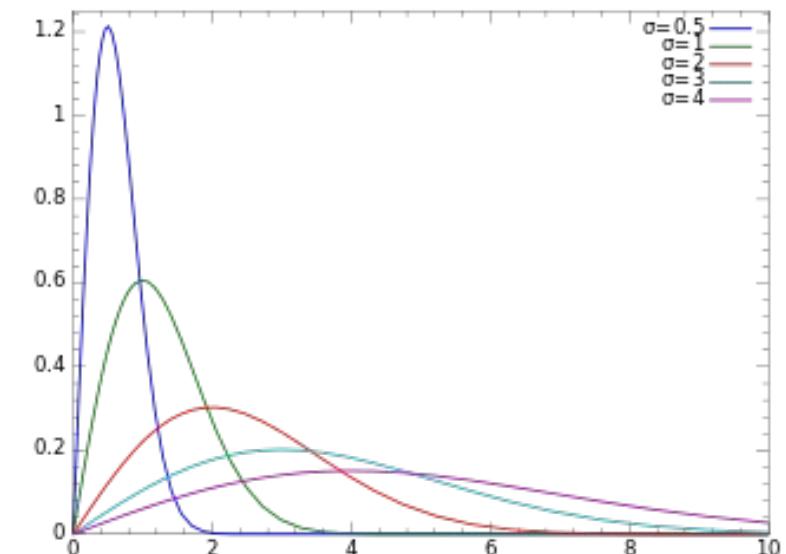
Probability functions for transmitted and received information.....

Likelihood function of SNR (amplitude and/or phase)

Rayleigh PDF for our received signal, corrupted by AWGN:

$$p_r(r_1, r_2) = \frac{1}{2\pi\sigma_r^2} e^{-\left[\frac{(r_1 - \sqrt{\epsilon_s})^2 + r_2^2}{2\sigma_r^2}\right]}$$

(Rayleigh >> Ricean >> Gaussian)



Joint Probability Density Function for Voltage and Phase:

$$p_{V_r, \theta_r}(V_r, \theta_r) = \frac{V_r}{2\pi\sigma_r^2} e^{-\left[\frac{V_r^2 + \epsilon_s - 2\sqrt{\epsilon_s}V_r \cos(\theta_r)}{2\sigma_r^2}\right]}$$

Integrate over all angles to get a PDF for Voltage:

$$p_V(V) = \int_{-\pi}^{\pi} p(V_r, \theta_r) d\theta = \frac{V_r}{\sigma_r^2} \cdot \frac{1}{2\pi} \cdot e^{-(V^2 + \epsilon_s)/2\sigma_r^2} \cdot \int_{-\pi}^{\pi} e^{\left[\frac{V_r \sqrt{\epsilon_s}}{\sigma_r^2} \cos \theta\right]} d\theta$$

Integrate over all Voltages to get a PDF for Phase:

$$p_{\theta_r}(\theta_r) = \int_0^{\infty} p(V_r, \theta_r) dV_r = \frac{1}{2\pi\sigma_r^2} \int_0^{\infty} V_r e^{-\left[\frac{V_r^2 + \epsilon_s - 2\sqrt{\epsilon_s}V_r \cos(\theta_r)}{2\sigma_r^2}\right]} dV_r$$

(This is useful for investigating interferometric methods, LLRF resolution, etc.)

Now, sigma can be extracted, from which Confidence Intervals may be established.....
eg. 95% = Est +/- 1.96 sigma T-scores, etc.....

Position Accuracy (cont.)

Good news...we can measure with G-Line!

Ibeam ~ 500nA

B = 10 Hz

$\sigma = 77 \mu\text{m}$

R = 120 μm

Ibeam ~ 100nA

B = 100 Hz

$\sigma = 100 \mu\text{m}$

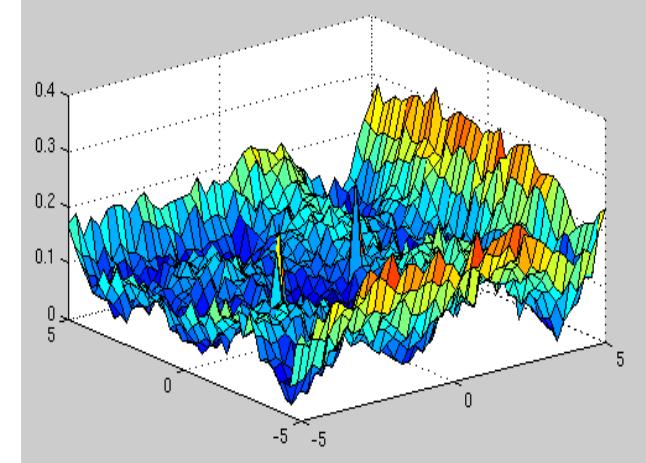
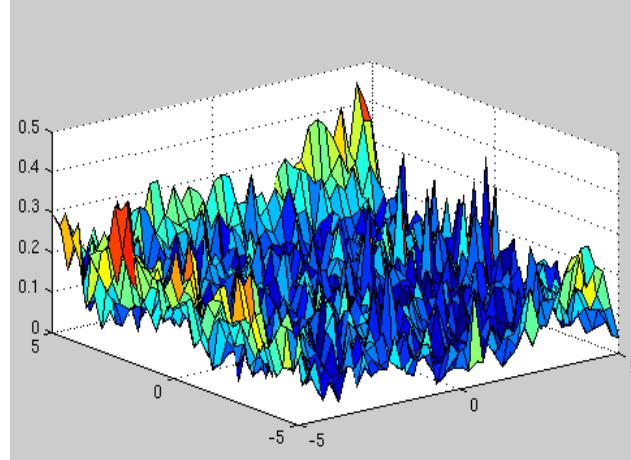
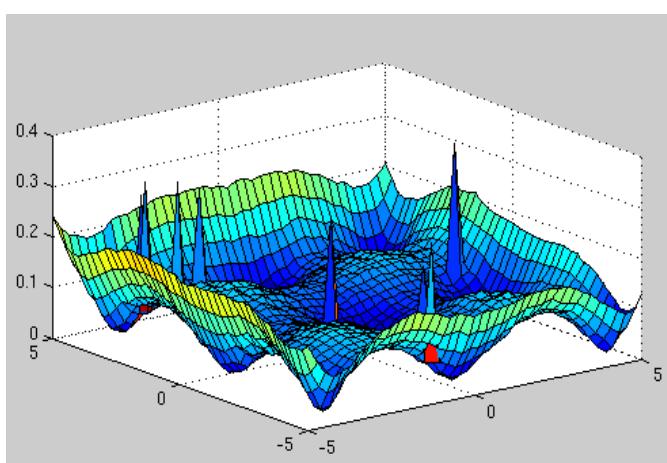
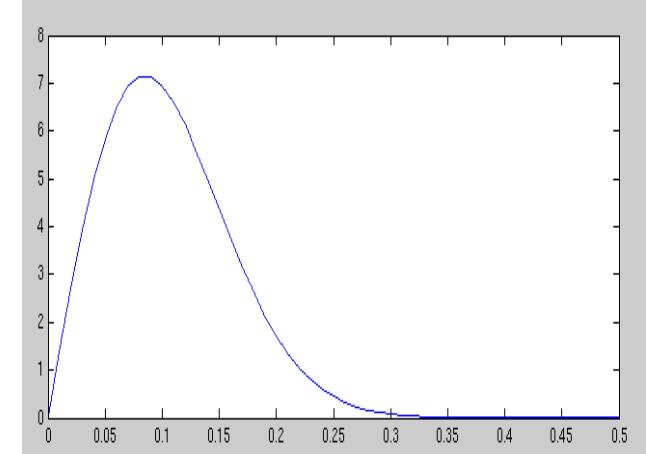
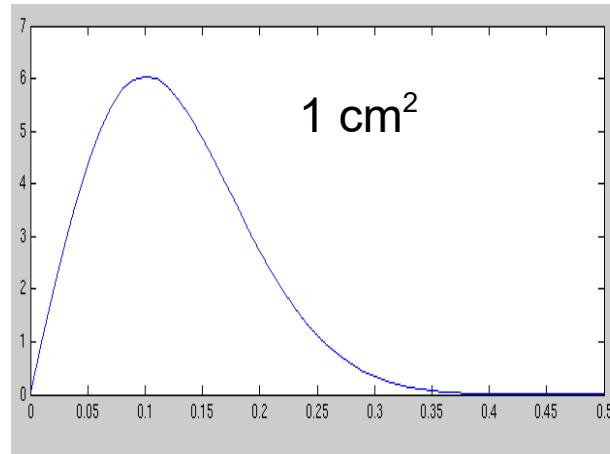
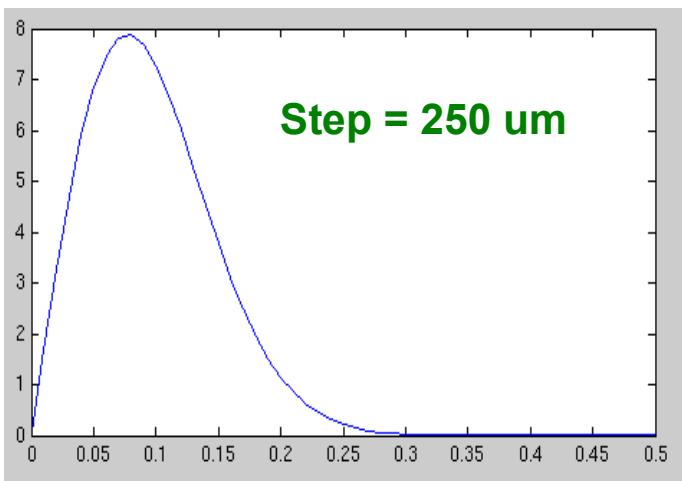
R = 158 μm

Ibeam ~ 100nA

B = 10 Hz

$\sigma = 85 \mu\text{m}$

R = 133 μm



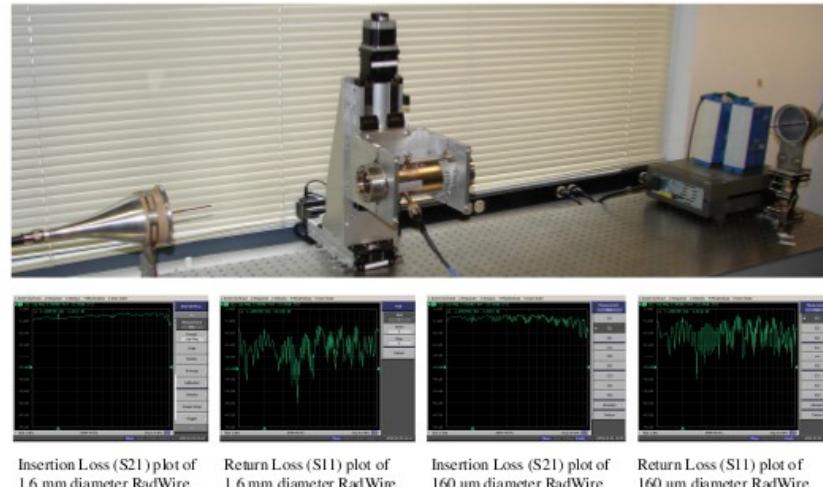
Application Of Goubau Surface Wave Transmission Line For Improves Bench Testing Of Diagnostic Beamline Elements*

J. Musson, K. Cole, Thomas Jefferson National Accelerator Facility, Newport News, VA
S. Rubin, Rubytron, Port Chester, NY

Abstract

In-air test fixtures for beamline elements typically utilize an X-Y positioning stage, and a wire antenna excited by RF source. In most cases, the antenna contains a standing wave, and is useful only for coarse alignment measurements in CW mode. A surface-wave (SW) based transmission line permits RF energy to be launched on the wire, travel through the beamline component, and then be absorbed in a load. Since SW transmission lines employ travelling waves, the RF energy can be made to resemble the electron beam, limited only by ohmic losses and dispersion. Although lossy coaxial systems are also a consideration, the diameter of the coax introduces large uncertainties in centroid location. A SW wire is easily constructed out of 200 micron magnet wire, which more accurately approximates the physical profile of the electron beam. Benefits of this test fixture include accurate field mapping, absolute calibration for given beam currents, Z-axis independence, and temporal response measurements of sub-nanosecond pulse structures. Descriptions of the surface wave launching technique, transmission line, and instrumentation are presented, along with measurement data.

Goubau Line/BPM Test Fixture

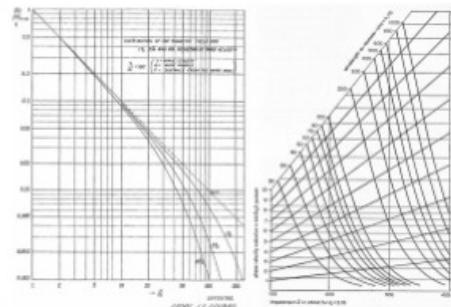


Goubau

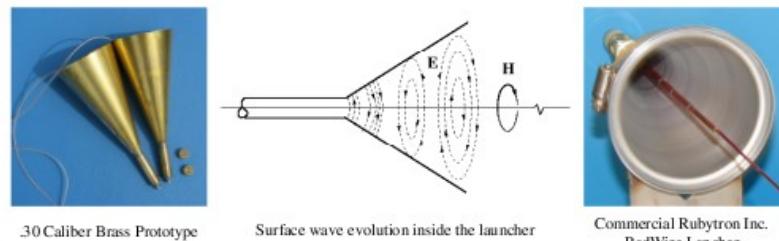
Georg Goubau (1899) was born in Münich, Germany, on November 18, 1899. He received the Dipl. Phys. degree in 1916, and the Dr. Ing. degree in 1931, both from the Munich Technical University. From 1911 to 1939 he was employed in research and teaching in the physics department of the same university, under Professor Zener. During this time he was principally concerned with ionometric investigations. He established the first German Ionospheric Research Station (Hörstorf/Rostock), and was in charge of the research work carried out there. In 1939 Dr. Goubau was appointed professor and director of the department of applied physics at the Friedrich-Schiller University of Jena, Germany. While he remained in this country, he was the senior author of the volumes on electronics of the FIAT Review of German Science, published by the Military Government for Germany. Dr. Goubau died a consultant at the Signal Corps Engineering Laboratories, in Fort Monmouth, N. J.



RUBYTRON



Development Of Surface Wave Launcher



Conclusions

Traditional bench testing of beamline components will be inadequate to characterize and assess performance of the 12 GeV upgrade at Jefferson lab. The use of the G-line facilitates measurements which more accurately mimic electron beam conditions. This system is particularly well-suited for our bench system, due to ease of fabrication, low-cost, and choice of operating frequency range. In addition, due to the flat 8 GHz frequency response, pulsed beam structures can be replicated, providing a platform for receiver development. Further reduction of VSWR is planned, in order to minimize dispersion of pulses resulting from reflections. Finally, the use of ~1 um X-Y stages presents a system which can be automated, improving repeatability and simplifying test procedures.

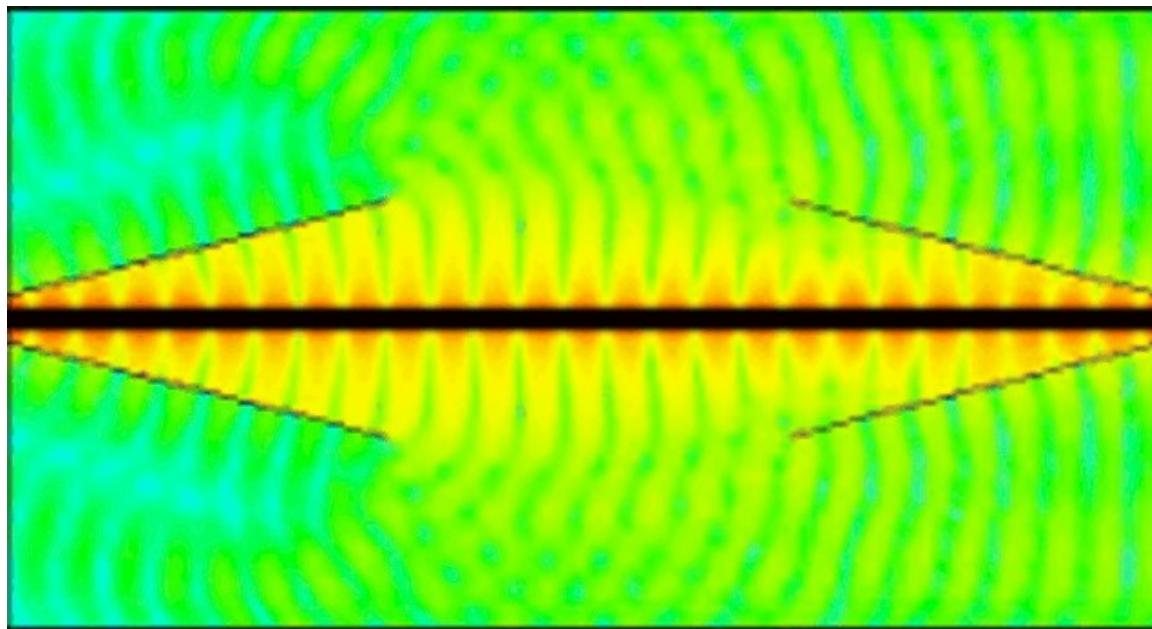


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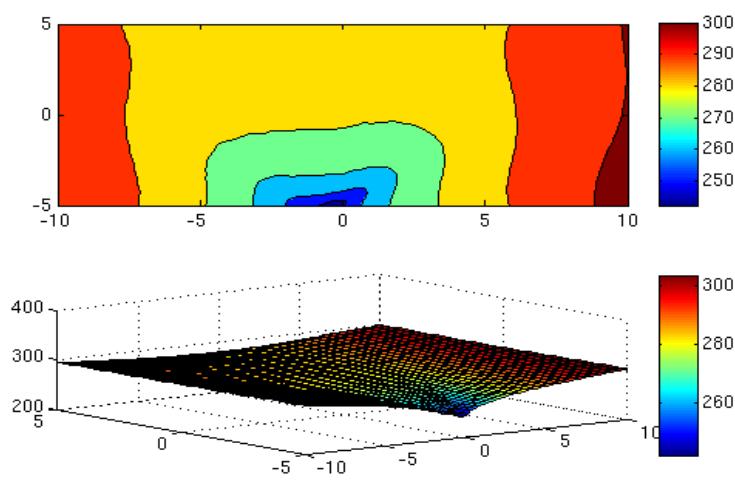
*Authored by Jefferson Science Associates, LLC under U.S. DOE Contract No. DE-AC05-06OR23177. The U.S. Government retains a non-exclusive, paid-up, irrevocable, worldwide license to publish or reproduce this manuscript for U.S. Government purposes.



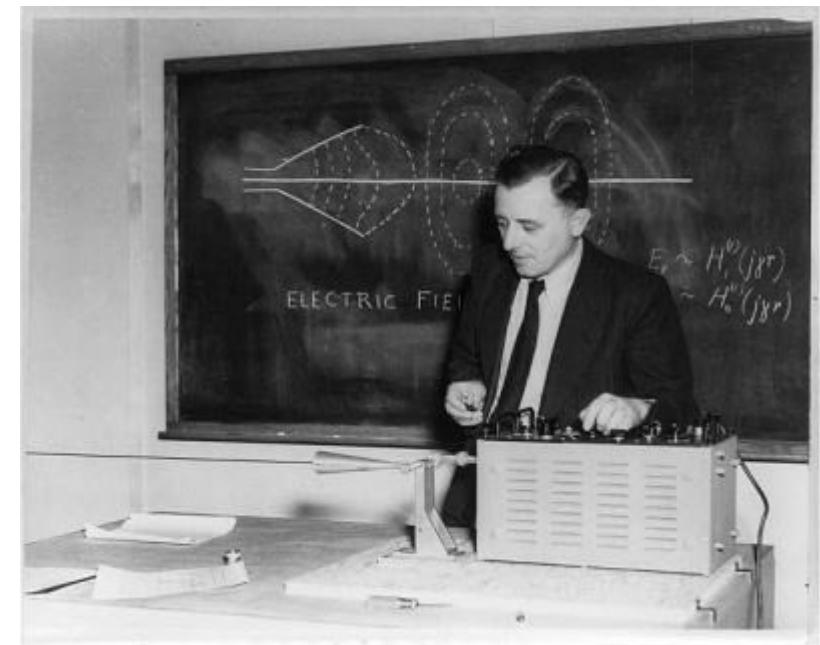
Jefferson Science Associates, LLC
a SURFACE CSC Company
Jefferson Lab



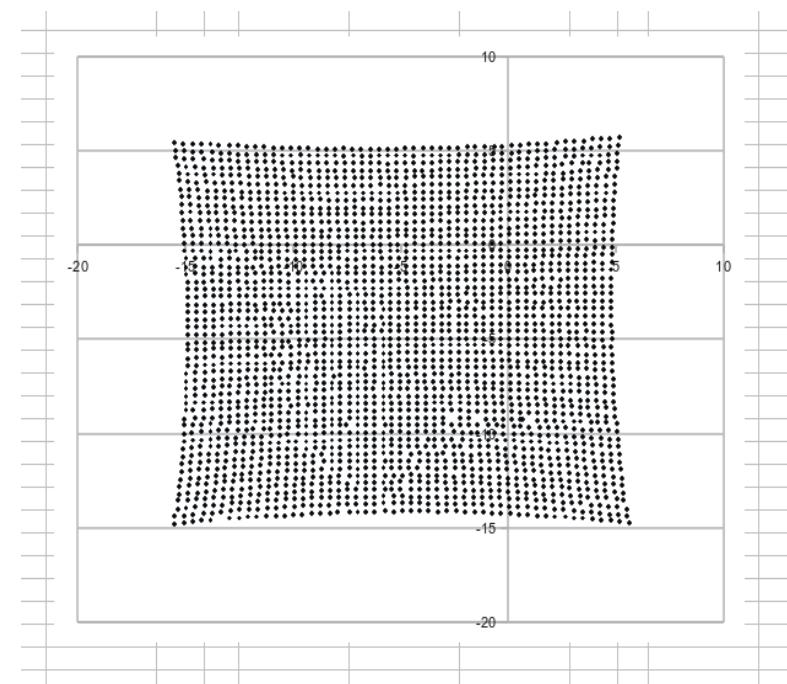
Goubau Line Animation



Single Button-electrode Scan



Georg!!

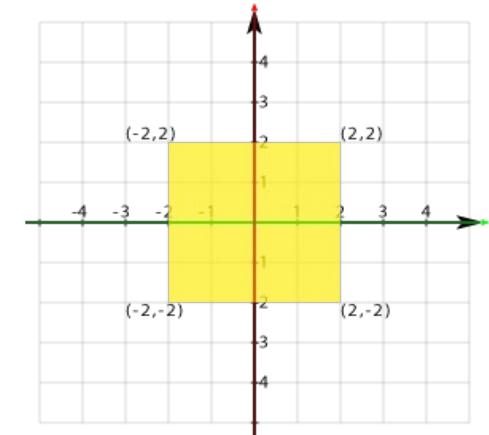
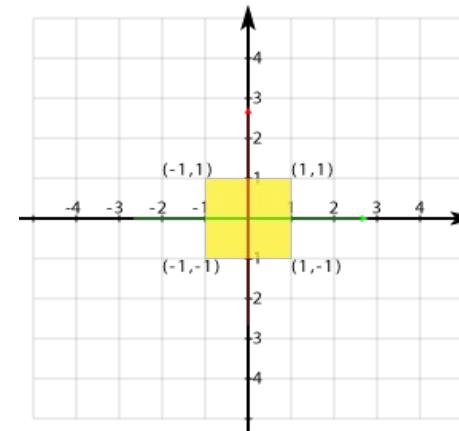


Prototype Sensor Scan

LMS 2-D Field Map Transformations

- Translation

$$\begin{bmatrix} x' \\ y' \\ 1 \end{bmatrix} = \begin{bmatrix} 1 & 0 & d_x \\ 0 & 1 & d_y \\ 0 & 0 & 1 \end{bmatrix} \begin{bmatrix} x \\ y \\ 1 \end{bmatrix}$$

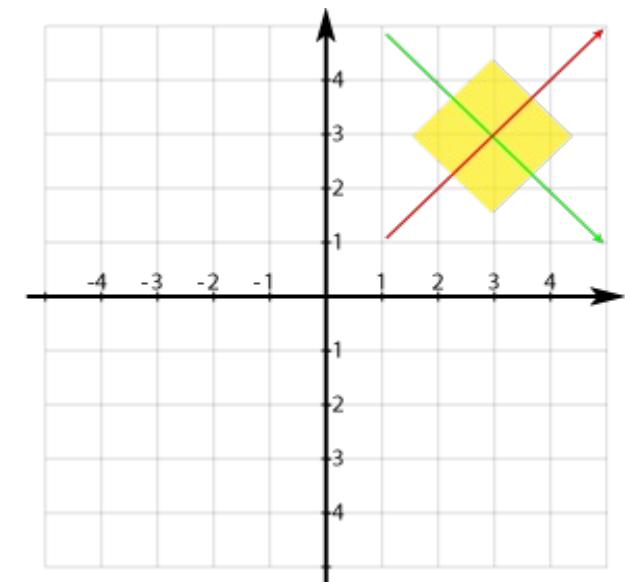
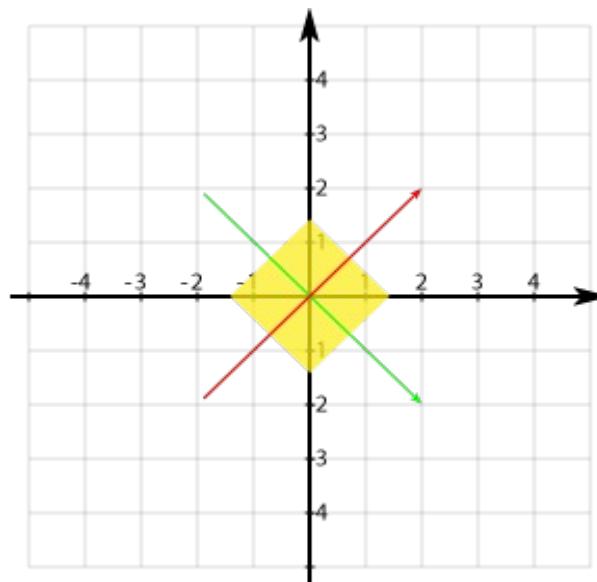
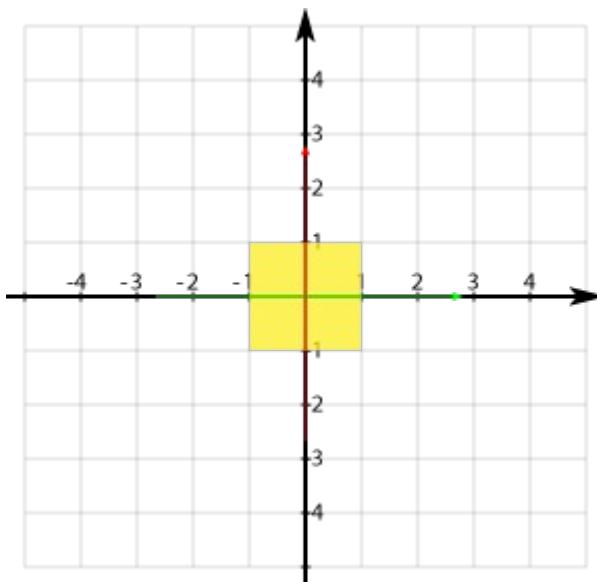


- Scaling

$$\begin{bmatrix} x' \\ y' \\ 1 \end{bmatrix} = \begin{bmatrix} s_x & 0 & 0 \\ 0 & s_y & 0 \\ 0 & 0 & 1 \end{bmatrix} \begin{bmatrix} x \\ y \\ 1 \end{bmatrix}$$

- Rotation

$$\begin{bmatrix} x' \\ y' \\ 1 \end{bmatrix} = \begin{bmatrix} \cos\theta & -\sin\theta & 0 \\ \sin\theta & \cos\theta & 0 \\ 0 & 0 & 1 \end{bmatrix} \begin{bmatrix} x \\ y \\ 1 \end{bmatrix}$$



LMS Process

$$X_{\text{meas}} = \frac{X_+ - X_-}{X_+ + X_-} = R \cos \theta$$

$$Y_{\text{meas}} = \frac{Y_+ - Y_-}{Y_+ + Y_-} = R \sin \theta$$

$$X_{\text{proper}} = K_x \cdot X_{\text{meas}} = K_x \cdot R \cos(\theta - \Delta\theta)$$

$$Y_{\text{proper}} = K_y \cdot Y_{\text{meas}} = K_y \cdot R \sin(\theta - \Delta\theta)$$

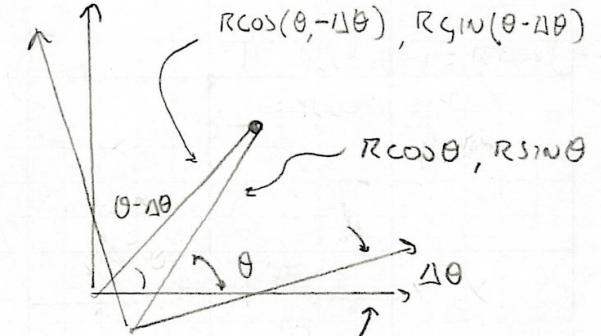
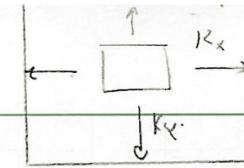
Extract $\Delta\theta$:

$$\cos(\alpha - \beta) = \cos \alpha \cos \beta + \sin \alpha \sin \beta$$

$$\sin(\alpha - \beta) = \sin \alpha \cos \beta - \cos \alpha \sin \beta$$

$$X_{\text{proper}} = K_x R \cos \theta \cos \Delta\theta + K_x R \sin \theta \sin \Delta\theta$$

$$= K_x \cos \Delta\theta \cdot X_{\text{meas}} + K_x \sin \Delta\theta \cdot Y_{\text{meas}} = K_x X_{\text{meas}} + K_y Y_{\text{meas}}$$



Combine rotation and scaling

(Marion, 1970)

$$\begin{aligned}
 Y_{\text{proper}} &= K_y R \sin \theta \cos \Delta \theta - K_y R \cos \theta \sin \Delta \theta \\
 &= K_y \cos \Delta \theta Y_{\text{mem}} - K_y \sin \Delta \theta X_{\text{mem}} = -\alpha_y X_{\text{mem}} + \beta_y Y_{\text{mem}}
 \end{aligned}$$

$$\alpha_x = K_x \cos \Delta \theta$$

$$\beta_x = K_x \sin \Delta \theta$$

$$\alpha_y = -K_y \sin \Delta \theta$$

$$\beta_y = K_y \cos \Delta \theta$$

Now, ADD Transposition:

$$X_{\text{proper}} = \alpha_x X_{\text{mem}} + \beta_x Y_{\text{mem}} + \Delta X$$

$$Y_{\text{proper}} = \alpha_y X_{\text{mem}} + \beta_y Y_{\text{mem}} + \Delta Y$$

$$\text{Let } X = X_{\text{proper}}$$

$$Y = Y_{\text{proper}}$$

$$\begin{aligned}x_1 &= \alpha_x X_{mens_1} + \beta_x Y_{mens_1} + \Delta x & \alpha_x = k_x \cos \alpha \theta \\y_1 &= \alpha_y X_{mens_1} + \beta_y Y_{mens_1} + \Delta y & \beta_x = k_x \sin \alpha \theta \\&\vdots & \\x_n &= \alpha_x X_{mens_n} + \beta_x Y_{mens_n} + \Delta x\end{aligned}$$

$$\begin{aligned}y_1 &= \alpha_y X_{mens_1} + \beta_y Y_{mens_1} + \Delta y & \alpha_y = -k_y \sin \alpha \theta \\y_2 &= \alpha_y X_{mens_2} + \beta_y Y_{mens_2} + \Delta y & \\&\vdots & \\y_n &= \alpha_y X_{mens_n} + \beta_y Y_{mens_n} + \Delta y & \beta_y = k_y \cos \alpha \theta\end{aligned}$$

$$\begin{bmatrix}x_1 \\ x_2 \\ \vdots \\ x_n\end{bmatrix} = \lambda \begin{bmatrix}\alpha_x \\ \beta_x \\ \Delta x\end{bmatrix} \quad \begin{bmatrix}y_1 \\ y_2 \\ \vdots \\ y_n\end{bmatrix} = \lambda \begin{bmatrix}\alpha_y \\ \beta_y \\ \Delta y\end{bmatrix}$$

$$\lambda = \begin{bmatrix}X_{mens_1} & Y_{mens_1} & 1 \\ X_{mens_2} & Y_{mens_2} & 1 \\ \vdots & \vdots & \vdots \\ X_{mens_n} & Y_{mens_n} & 1\end{bmatrix}$$

function,

$$\begin{bmatrix}\alpha_x \\ \beta_x \\ \Delta x\end{bmatrix} = \lambda^{-1} \begin{bmatrix}x_1 \\ x_2 \\ \vdots \\ x_n\end{bmatrix}$$

$$\begin{bmatrix}\alpha_y \\ \beta_y \\ \Delta y\end{bmatrix} = \lambda^{-1} \begin{bmatrix}y_1 \\ y_2 \\ \vdots \\ y_n\end{bmatrix}$$

USA "Pseudo-Inverse": (MORG-PENROSE, RAO, MITRA, 1971)

$$\lambda^{-1} = (\lambda^T \lambda)^{-1} \lambda^T$$

so,

$$\begin{bmatrix}\alpha_x \\ \beta_x \\ \Delta x\end{bmatrix} = (\lambda^T \lambda)^{-1} \lambda^T \begin{bmatrix}x_1 \\ x_2 \\ \vdots \\ x_n\end{bmatrix}$$

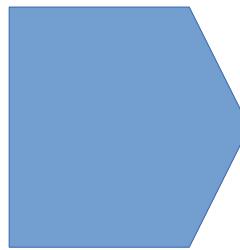
, Least MSE
(BISHOP, 2006)

$$\begin{bmatrix}\alpha_y \\ \beta_y \\ \Delta y\end{bmatrix} = (\lambda^T \lambda)^{-1} \lambda^T \begin{bmatrix}y_1 \\ y_2 \\ \vdots \\ y_n\end{bmatrix}$$

, Least MSE
(BISHOP, 2006)

Physical Significance of LMS Residuals

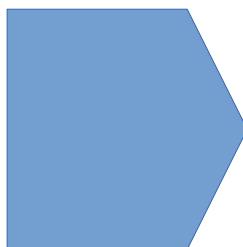
$$X_{scale\ factor} = \sqrt{\alpha_x^2 + \beta_x^2}$$



Scale factors for X and Y directions

$$Y_{scale\ factor} = \sqrt{\alpha_y^2 + \beta_y^2}$$

$$\theta_x = \tan^{-1}\left(\frac{\beta_x}{\alpha_x}\right)$$



X and Y “effectively” rotated individually

$$\theta_y = \tan^{-1}\left(\frac{\beta_y}{\alpha_y}\right)$$

$$\Delta \theta = \theta_y - \theta_x$$



Differences in thetas represents X-Y coupling

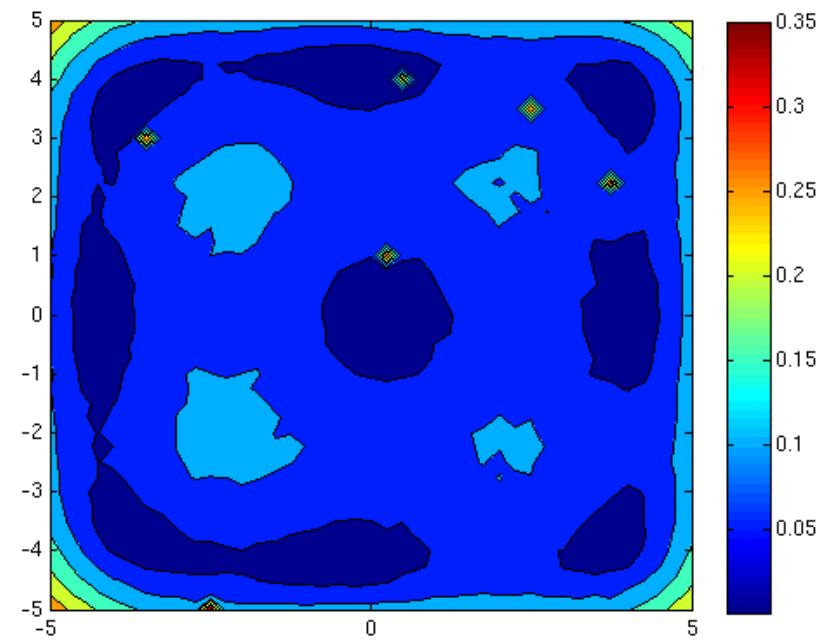
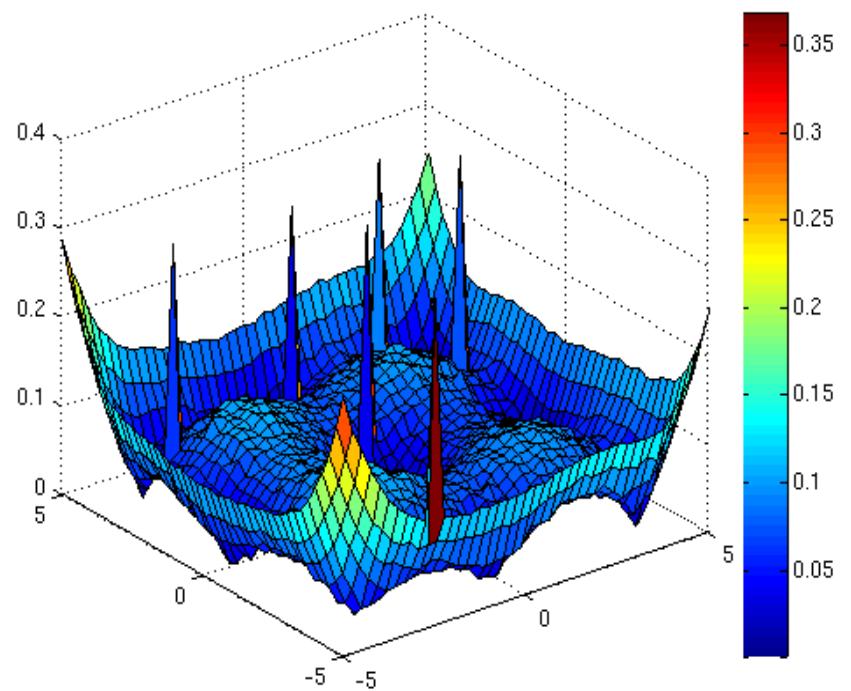
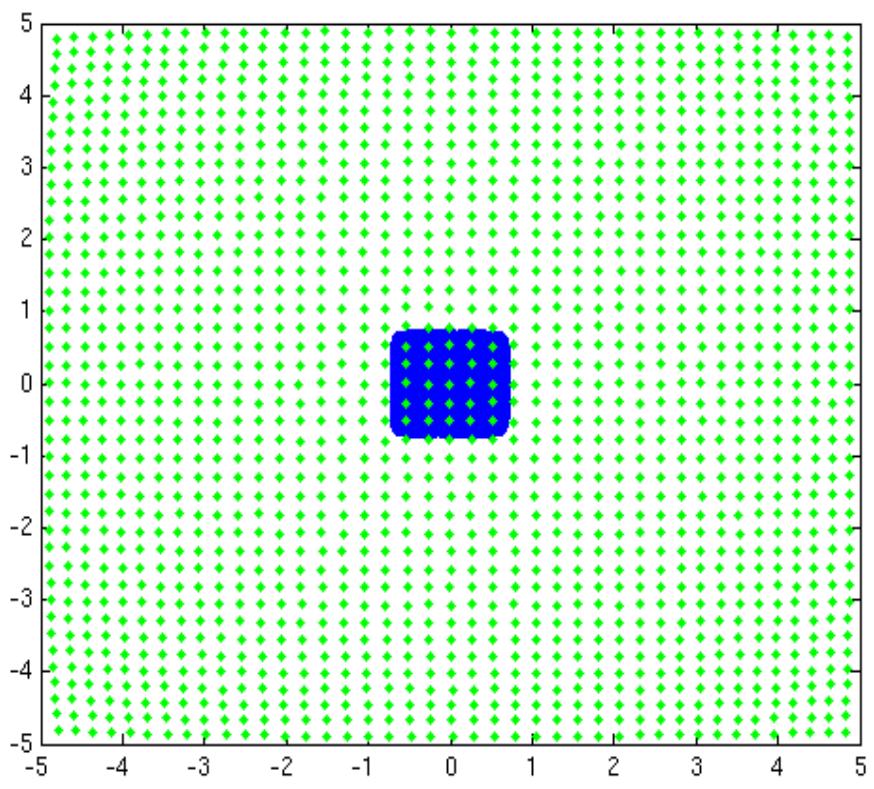
$$\Delta_x, \Delta_y$$



Arbitrary field offset;

Merely tells us where we “should” have started the scan

Not related to physical vs. electrical centers (obtained later)



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